

JG00143  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#7 Election  
V. Hu  
1-15-03

Applicant(s): Yu et al.

: Date: 7 January 2003

Serial No.: 09/842,734

: Group Art Unit: 2811

Filed: 26 April 2001

: Examiner: S. Hu

For: STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR  
STRUCTURES AND DEVICES USING BINARY METAL OXIDE LAYERS

## CERTIFICATION OF FACSIMILE TRANSMISSION

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING FACSIMILE  
TRANSMITTED TO THE UNITED STATES PATENT AND TRADEMARK  
OFFICE ON THE DATE SHOWN BELOW.

Sally Hartway  
Type Name of Person Signing Certification

[Signature] 1-7-03  
SIGNATURE DATE

FAX RECEIVED

RESPONSE TO RESTRICTION REQUIREMENT

JAN 7 - 2003

TECHNOLOGY CENTER 2800

Honorable Commissioner of Patents and Trademarks,  
Washington, D.C. 20231

SIR:

In response to the Office Action dated 9 December 2002, please consider the  
remarks for the above identified application as follows:

## REMARKS

The claims in this Application was previously restricted to claims 1-38.

This response is to the Office Action requiring the election of a species from  
one of six identified by the Examiner.